



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toru YAMADA

Group Art Unit: 1714

Application No.: 10/582,802

Examiner: G. RAO

Filed: June 14, 2006

Docket No.: 136170

For: VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING
EPITAXIAL WAFER

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 13, 2010 Restriction Requirement, Applicant provisionally elects
Group I, claims 1-6 and 10.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Michael D. Gagliano
Registration No. 62,037

WPB:MDG/mjb

Date: April 28, 2010

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION

Please grant any extension
necessary for entry of this filing;
Charge any fee due to our
Deposit Account No. 15-0461